



03500.013000.

PATENT APPLICATION

In re Application of:

Examiner: Lin Ye

YOSHIHIRO ISHIDA ET AL.

Group Art Unit: 2612

Appln. No.: 09/164,624

Filed: October 1, 1998

**For: MONITORING SYSTEM
APPARATUS AND
PROCESSING METHOD
(As Amended)**

February 6, 2004

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Technology Center 2600

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL ACTION

Sir:

Applicants petition to extend the time for response to the Office Action

dated October 6, 2003, to February 6, 2004. A check in payment of the extension fee is

enclosed; please charge any deficiency in this fee, and credit any overpayment, to Deposit

02/10/2004 DTESSEN1 00000073 09164624

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110.00 EP

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

February 6, 2004.

(Date of Deposit)

Leonard P. Diana

(Name of Attorney for Applicant)

February 6, 2004

Signature

Date of Signature

2/26/64

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